YWTO

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## PATENT APPLICATION

Applicant: Kim, et al.

Case: 7354 ALRT/ETCH/DRIE

Serial No.: 10/632,873

Filed: August 1, 2003

Examiner: George, Patricia Ann

Group Art Unit: 1765

Confirmation No.: 4644

Title:

SELECTIVE ETCHING OF CARBON-DOPED LOW-K DIELECTRICS

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

## **RESPONSE TO FINAL OFFICE ACTION DATED DECEMBER 11, 2006**

In response to the Final Office Action dated December 11, 2006, having a shortened statutory period for response set to expire on March 11, 2007, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although the Applicants believe that no fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 50-3562 for any fees required to make this response timely and acceptable to the Office.